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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8) Applicant(s): ARVID Neil ARVIDSON			Docket No. HSC27 DIV1
Application No. 10/796351	Filing Date	Examiner	Group Art Unit
Invention: Method and Apparatus for Improving Silicon Processing Efficiency			
	Response to Office Action		
(Identify type of correspondence)			
Is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>571-273-8300</u> )			
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### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.:

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Confirmation No.:

1989

Applicant:

ARVIDSON, et al.

Filed:

9 March 2004

TC/A.U.:

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Examiner:

Rodriguez, Joseph C.

Docket No.:

HSC27 DIV1

Customer No.:

00137

Date:

10 January 2006

For:

Method and Apparatus for Improving Silicon Processing Efficiency

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

#### **AMENDMENT**

Sir:

In response to the notice of non-compliant amendment dated 6 January 2006 please amend the above-identified application as follows.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 7 of this paper.